



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

ONO, Toshiaki et al.

Group Art Unit: 1765

Serial No.: 09/883,922

Examiner: ANDERSON, Matthew A.

Filed: June 20, 2001

Confirmation No.: 3735

For: **METHOD OF MANUFACTURING EPITAXIAL WAFER AND METHOD OF
PRODUCING SINGLE CRYSTAL AS MATERIAL THEREFOR**

Attorney Docket No.: 010789

Customer Number: 38834

AMENDMENT UNDER 37 C.F.R. §1.116

Mailstop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

March 3, 2004

Sir:

In response to the Office Action dated September 11, 2003, Applicant amends the claims as follows and submits the following remarks.

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.